

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q80822

Masatomo SHIBATA

Appln. No.: 10/813,176

Group Art Unit: 2813

Confirmation No.: 4446

Examiner: Dolan, Jennifer M.

Filed: March 31, 2004

For: III-V NITRIDE SEMICONDUCTOR SUBSTRATE AND ITS PRODUCTION METHOD

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Responsive to the outstanding rejection of September 15, 2006, please amend the above application as follows:

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